

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Applicants:

Date: February 14, 2008

Haight et al.

Group Art Unit: 1793

Serial No.: 09/933,461

Examiner: Geoffrey S. Evans

Filed: August 20, 2001

Docket No.: YOR919980510US2

For: METHOD FOR MINIMIZING SAMPLE DAMAGE DURING THE ABLATION OF
MATERIAL USING A FOCUSED ULTRASHORT PULSED LASER BEAM

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136(a)

1. This is a petition for an extension of time to respond to the Office Action dated
November 2, 2007 for a period of 1 months.

2. Applicant is other than a small entity.

3. Extension:

(months) _____

☒ one month

☐ two months

☐ three months

Fee for other than

small entity

\$ 120.00

\$ 450.00

\$1,020.00

Fee: \$120.00

4. An Amendment

☒ is filed herewith

☐ has been filed

5. Fee payment

☒ Charge fee to Deposit Account No. 09-0468 and for any additional extension fee
required or credit any excess fee paid.

Respectfully submitted,

IBM CORPORATION
Intellectual Property Law Department
P.O. Box 218
Yorktown Heights, New York 10598

By: /Daniel P Morris

Dr. Daniel P. Morris, Esq.

Reg. No.: 32,053

Telephone No.: (914) 945-3217